

INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

December 12, 2024

IGI Report Number

Description

Shape and Cutting Style

Measurements

LG669432928

LABORATORY GROWN DIAMOND

SQUARE EMERALD CUT

6.53 X 6.53 X 4.19 MM

GRADING RESULTS

Carat Weight

Color Grade

Clarity Grade

1.64 CARAT

E

VS 2

ADDITIONAL GRADING INFORMATION

Polish

Symmetry

Fluorescence


EXCELLENT

EXCELLENT

NONE

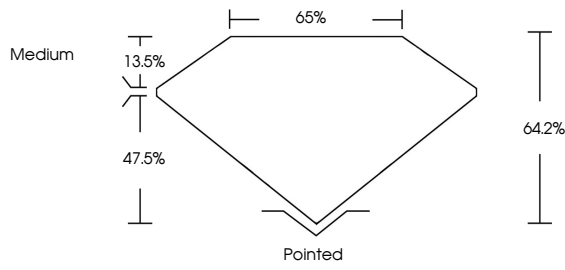
Inscription(s)

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

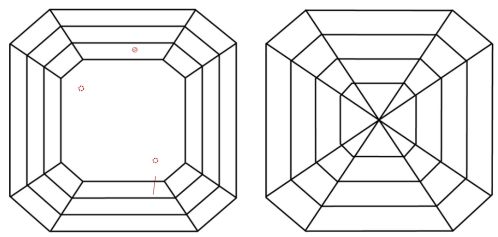
 LG669432928

Report verification at igi.org

PROPORTIONS



CLARITY CHARACTERISTICS




KEY TO SYMBOLS

Red symbols indicate internal characteristics.

Green symbols indicate external characteristics.

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E

VS 2

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
EXCELLENT

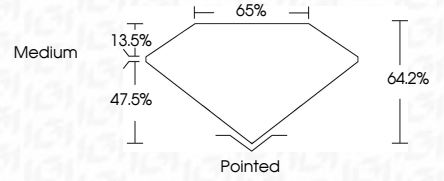
EXCELLENT

NONE


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December 12, 2024

IGI Report No LG669432928

SQUARE EMERALD CUT

6.53 X 6.53 X 4.19 MM

Carat Weight

Color Grade

Clarity Grade

Depth

Table

Girdle

Culet

Polish

Symmetry

Fluorescence

Inscription(s)

1.64 CARAT

E

VS 2

64.2%

65%

Medium

Pointed

EXCELLENT

EXCELLENT

NONE

 LG669432928

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